Search Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination	-
10/664,981	LEE ET AL.	
Examiner	Art Unit	
Chris C. Chu	2815	

	SEARCHED			
Class	Subclass	Date	Examiner	
257	686 & 687	4/8/2005	C.C.	
		-		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		-		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; and IBM_TDB;	4/8/2005	C.C.